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Attorney Docket No. UMC-96-279 CON
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Chih-Chien Liu, Ta-Shan Tseng, W. B. Shieh, J. Y.
Wu, Water Lur and Shih-Wei Sun

Serial No. 09/546,174

Filed: April 11, 2000

For: HIGH DENSITY PLASMA CHEMICAL
VAPOR DEPOSITION PROCESS

Group Art Unit: 1711

Examiner: Sergeant, Rabon A.

Confirmation No.: 4793

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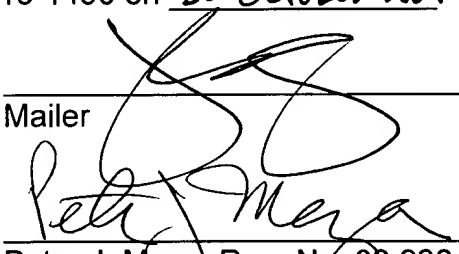
1. Request for Continued Examination with \$790 fee;
2. Information Disclosure Statement;
3. Form PTO/SB/08A, with reference and English translation;
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